INFORMATION DISCLOSURE CITATION IN AN APPLICATION

SEP 1 5 199

					July 6, 1999		1732				
U.S. PATENT DOCUMENTS											
*EXAMINER INITIAL		REF	DOCUMENT NO.	DATE	NAME		CLASS	SUBCLASS	FILING IF APPROP		
illo	NOV		5,728,324	3/17/98	Welch et al.		264	2.5	1/31/95		
4		В	5,825,741	10/20/98	Welch et al.		369	112	7/10/96		
		С	5,575,962	11/19/96	Takahashi		264	2.5	12/2/94		
			Liau et al.		264	1.1	9/27/9	94			
			Swanson	et al.	359	565	12/2/9	91			
	1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1 1		Hartman et al.		156	643	5/3/93	3			
		G	4,737,447	4/12/88	Suzuki et al.		430	321	6/9/86		
		Н	5,837,156	11/17/98	Cumming		249	119	9/30/96		
	I 5,876,642 3/2/99 Calderir		Calderini e	et al.	264	2.5	1/31/9	96			
		J	2,745,138	5/15/56	Beattie		18	26	5/26/5	53	
		K	4,874,561	10/17/89	Spector	· · ·	264	1.1	3/3/88	3	
		L	4,840,754	6/20/89	Brown et a	al.	264	2.2	11/9/8	37	
Utev		М	4,751,029	6/14/88	Swanson		264	40.4	10/22	/86	
				FOREIC	N PATEN	T DOCUMENTS	3				
		REF	DOCUMENT NO.	DATE	CC	OUNTRY	CLASS	SUBCLASS	Transla YES	tions NO	
	OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)										
μι	<i>J</i>	N	T. Fujita et al., "Blazed gratings and Fresnel lenses fabricated by electron-beam lithography", OPTICS LETTERS, Vol. 7. No. 12, Dec. 1982, pages 578-580.								

EXAMINER	DATE CONSIDERED						
Not Yet Assigned M. Vaugt	6/11/0ə						
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through							
citation if not in conformance and not considered. Include cop	y of this form with next communication to Applicant.						

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